

Figure 1: Molecular structure of [(NHC)Ag(hmds)].[1]

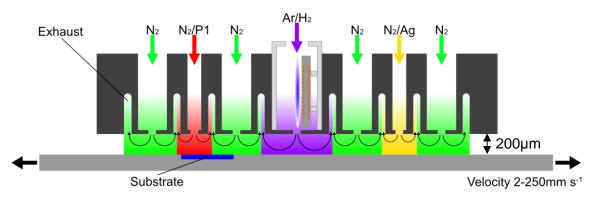


Figure 2: Schematic of the Plasma Enhanced Spatial ALD System.

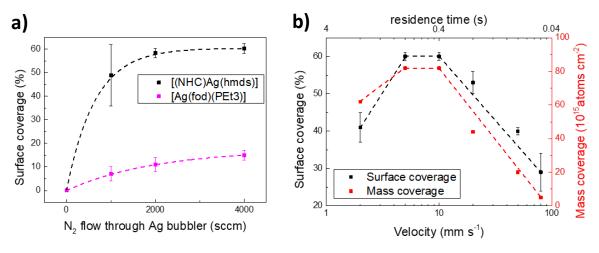


Figure 3: a): Surface coverage as a function of N_2 flow through the Ag bubbler for [(NHC)Ag(hmds)] and [Ag(fod)(PEt_3)] Precursor. Films are deposited at 100° C with a substrate velocity of v=5mm/s and 300 ALD cycles. b): Surface coverage(black) and mass coverage(red) as a function of the substrate velocity and residence time for the [(NHC)Ag(hmds)] precursor, respectively. Films are deposited at 100° C with an N_2 flow of 4000sccm through the Ag bubbler and 300 ALD cycles. Mass coverage was determined by Rutherford Backscattering Spectrometry.